

FIG. 1a

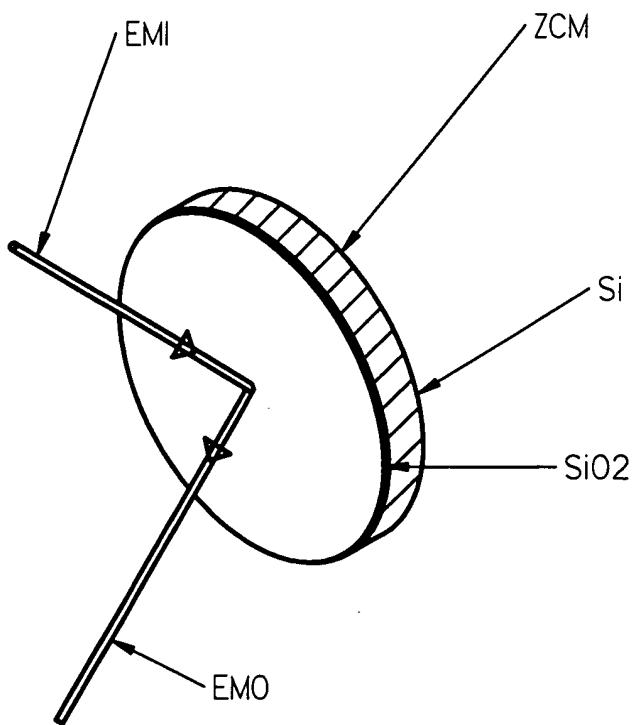
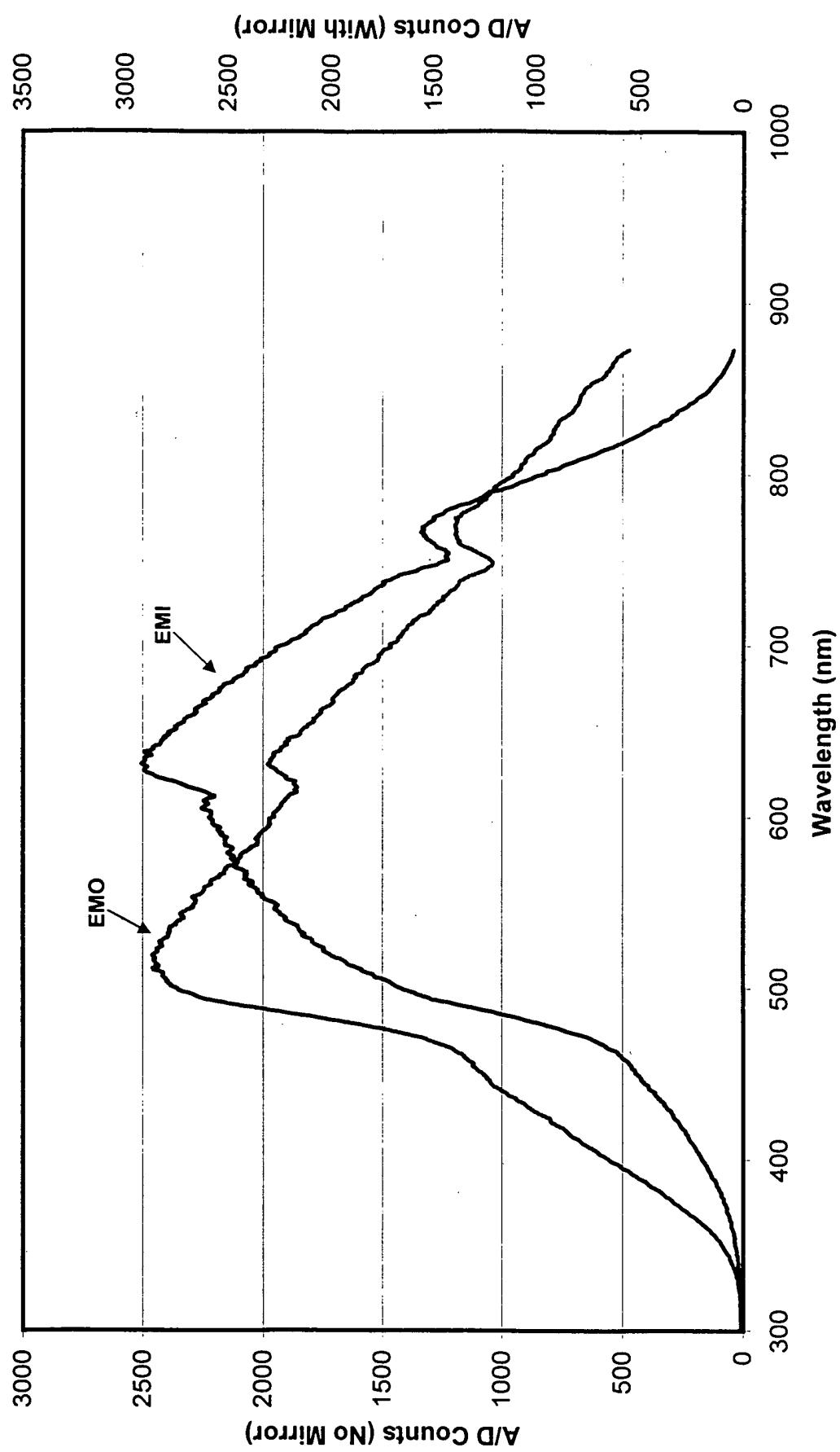


FIG. 1b

**Spectrum of SE with and without 1200Å SiO<sub>2</sub>/Si Mirror**



**FIG. 2**

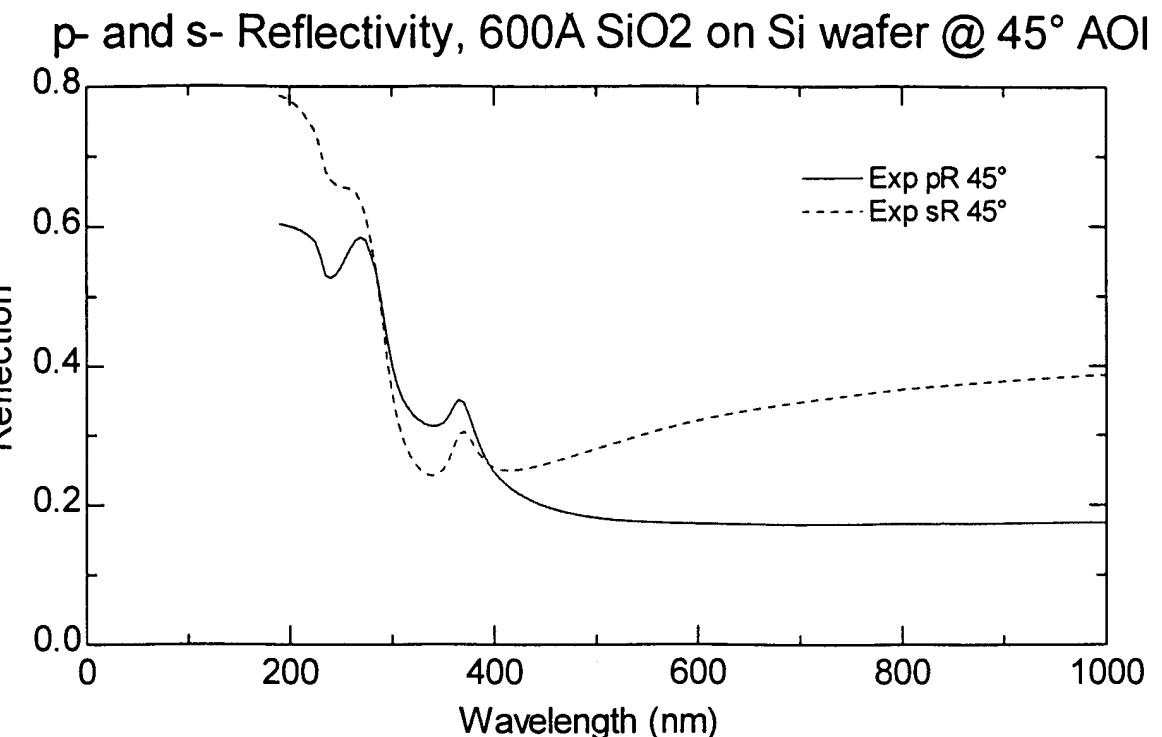


FIG.4

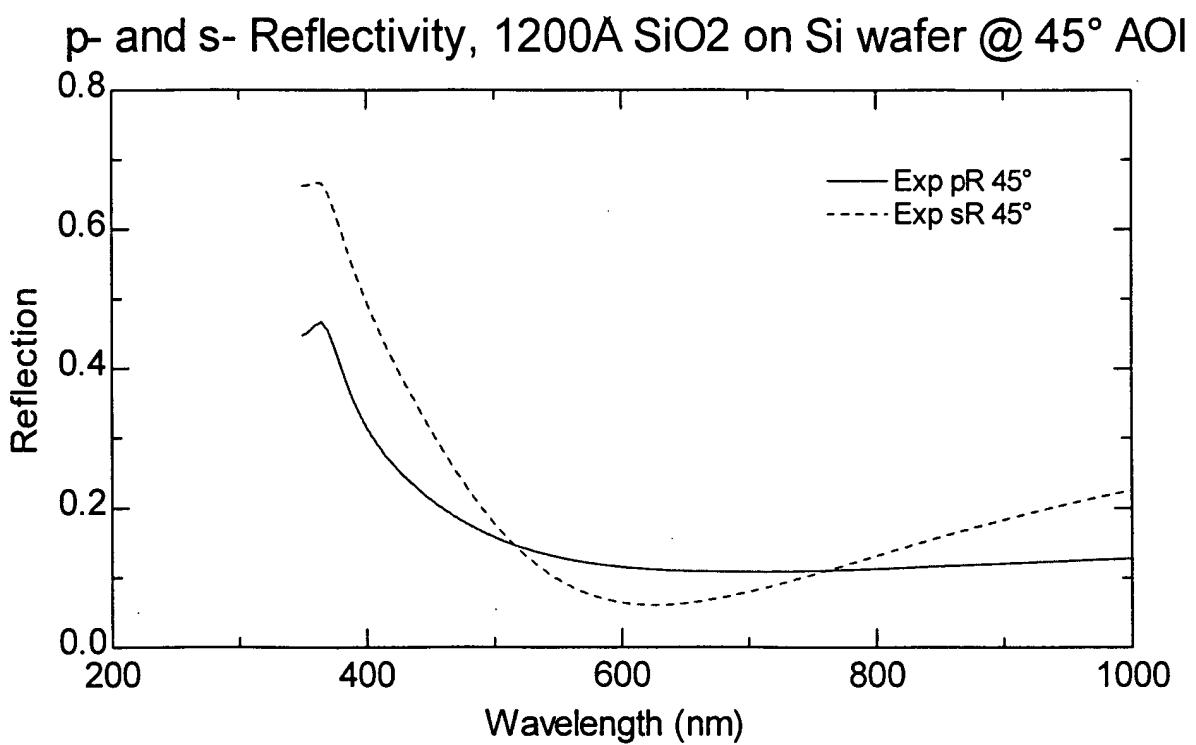


FIG. 3

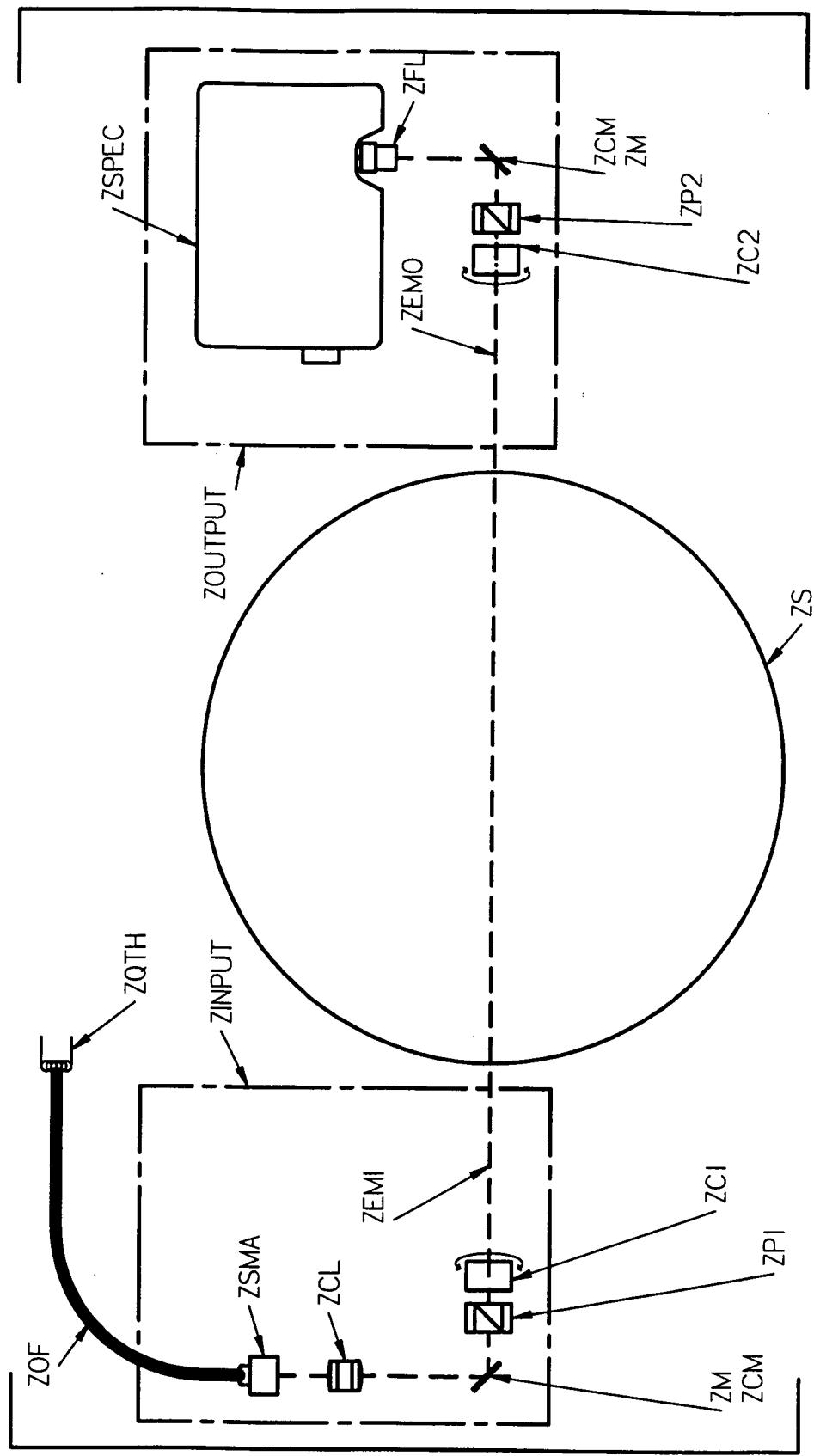


FIG. 5

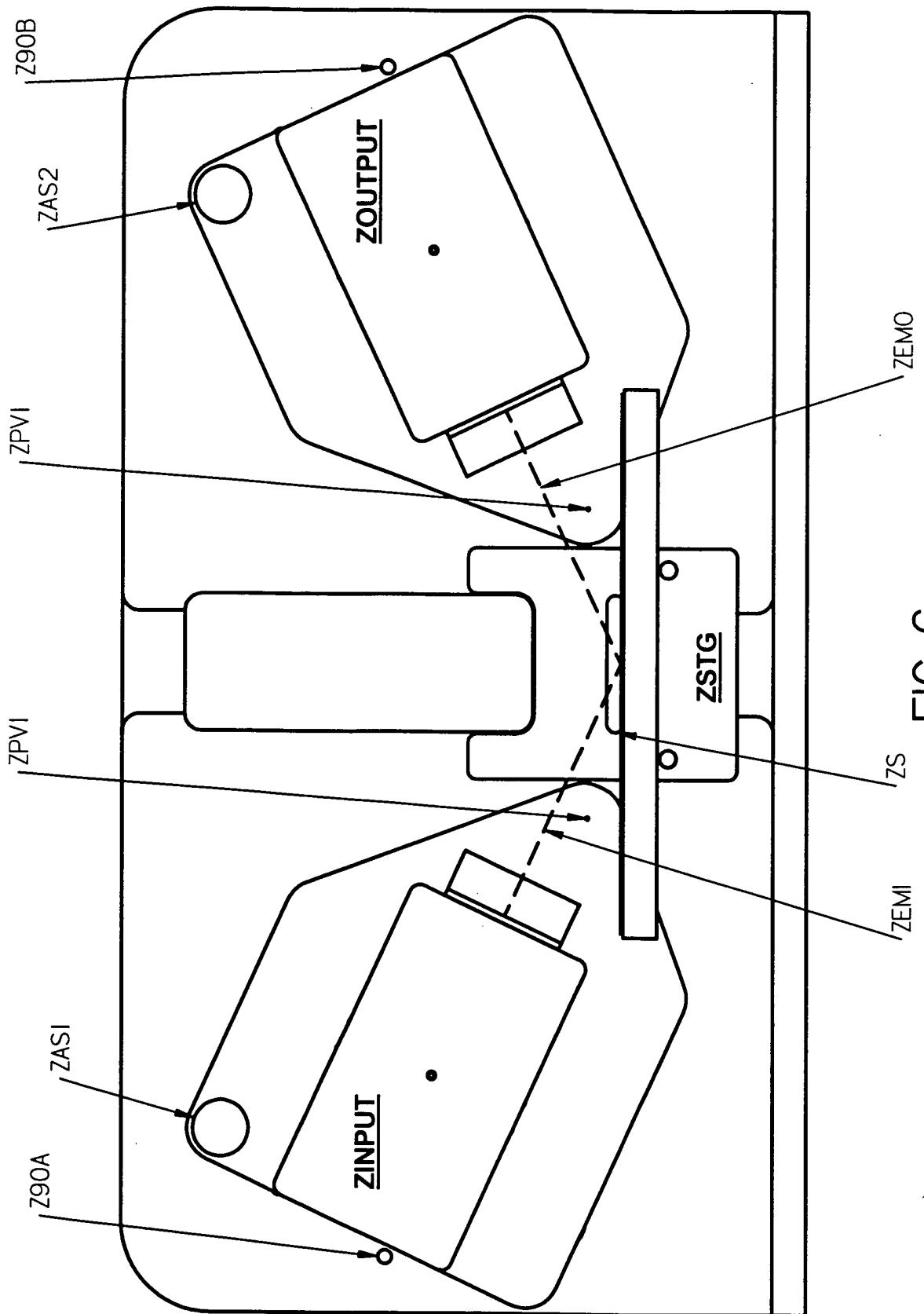


FIG. 6

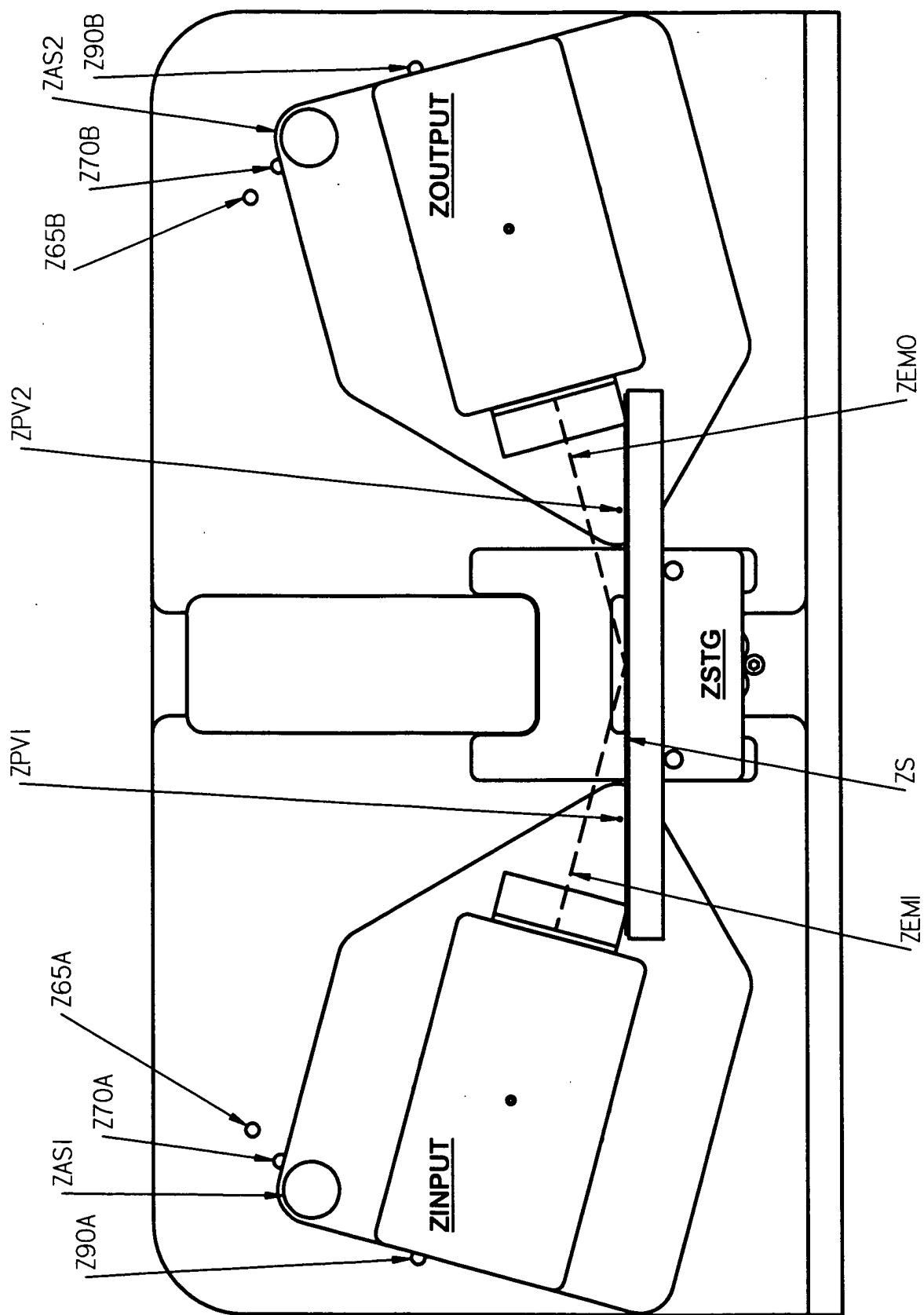


FIG. 7

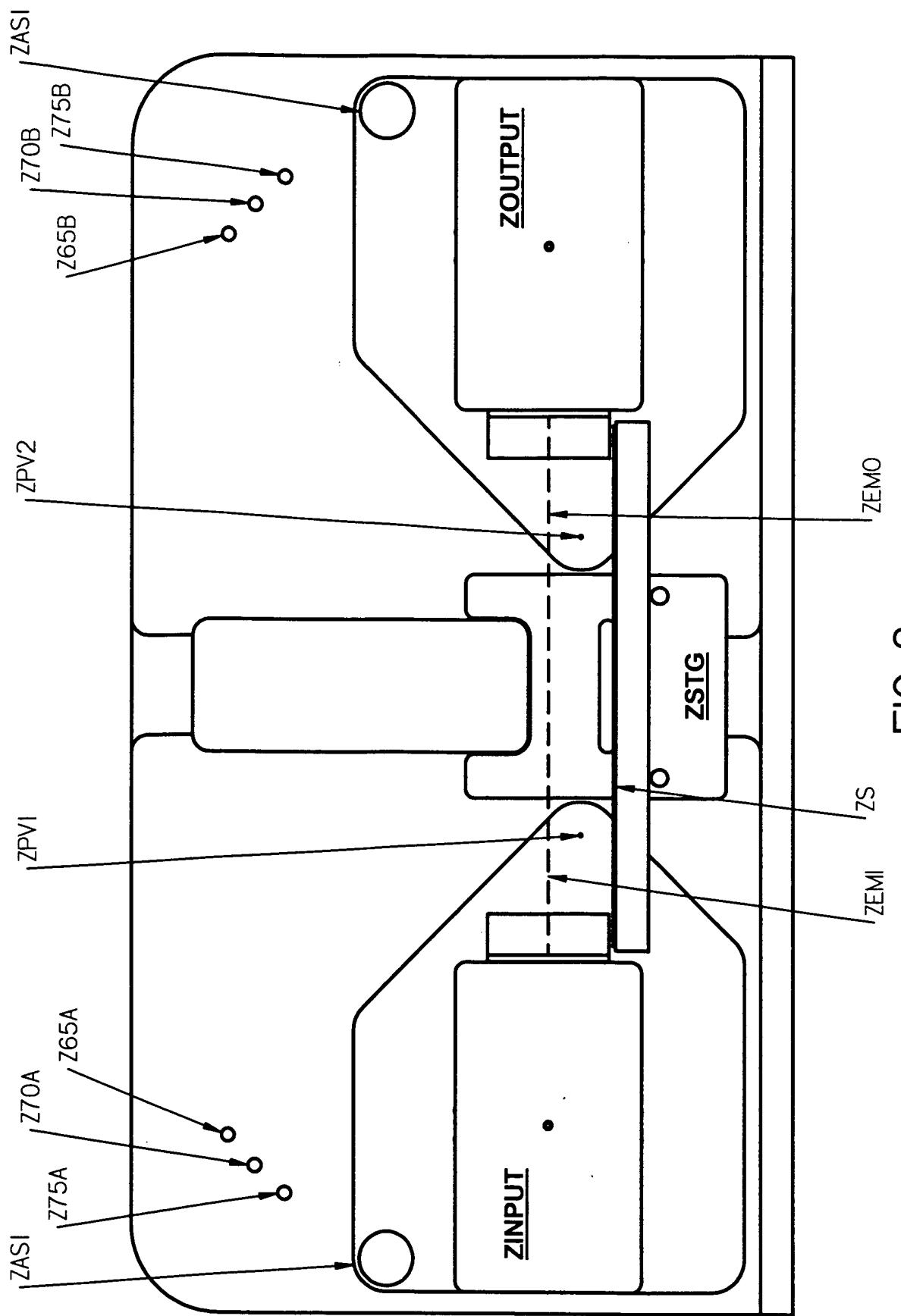


FIG. 8

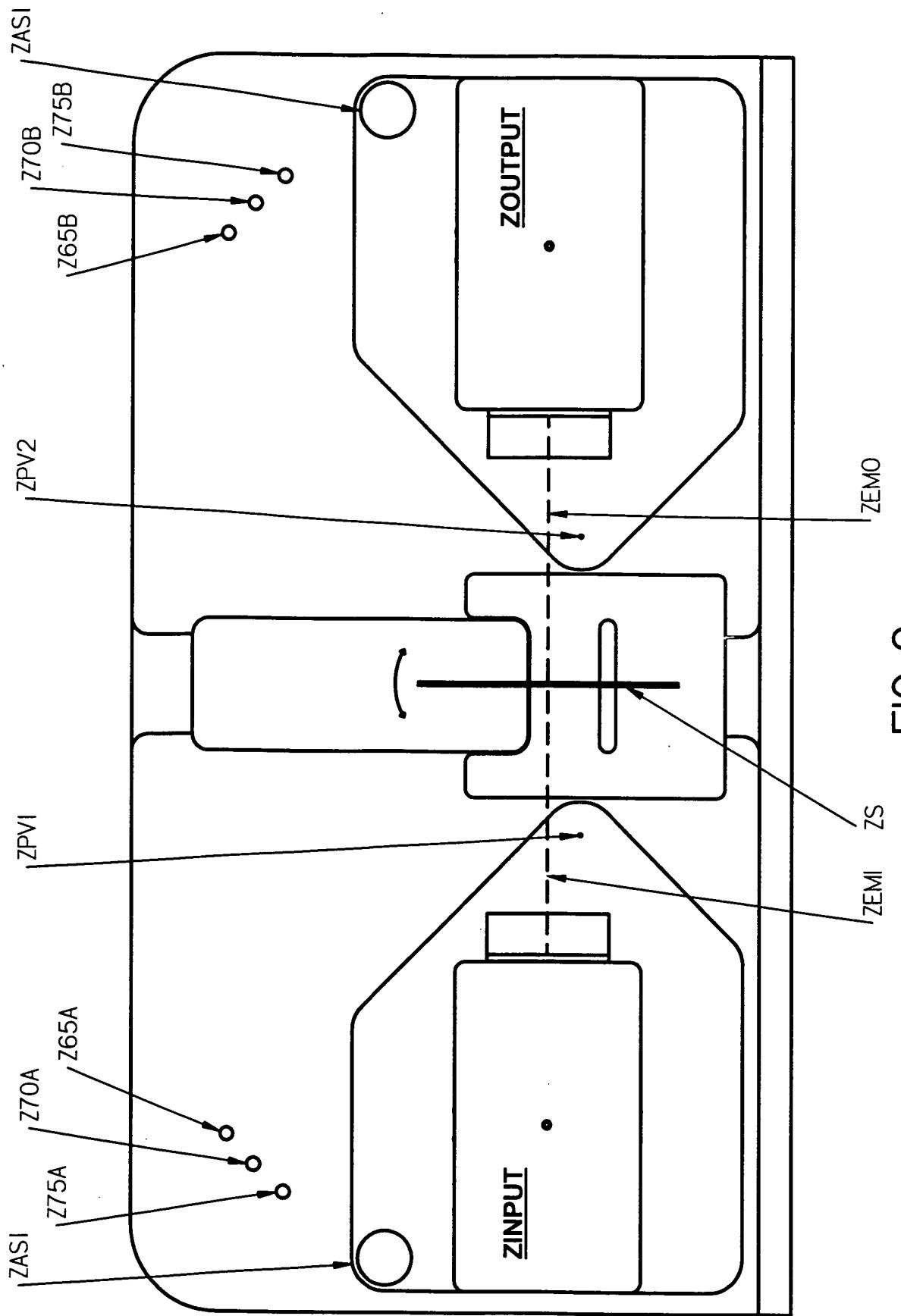


FIG. 9

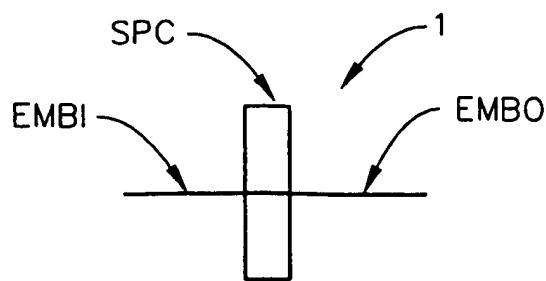


FIG. 10a



FIG. 10b

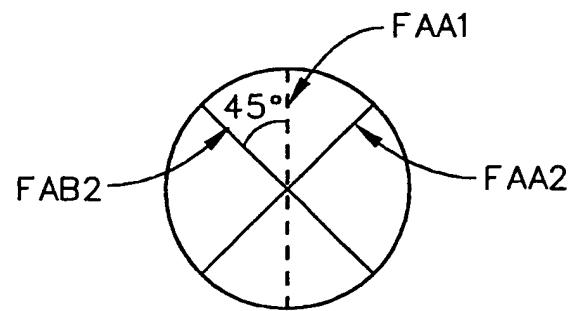
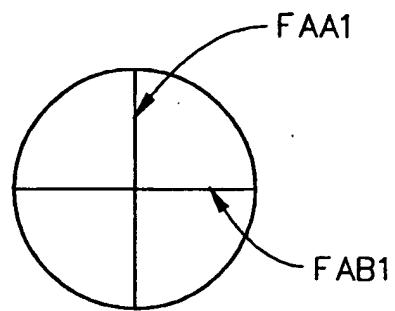


FIG. 10c

FIG. 10d

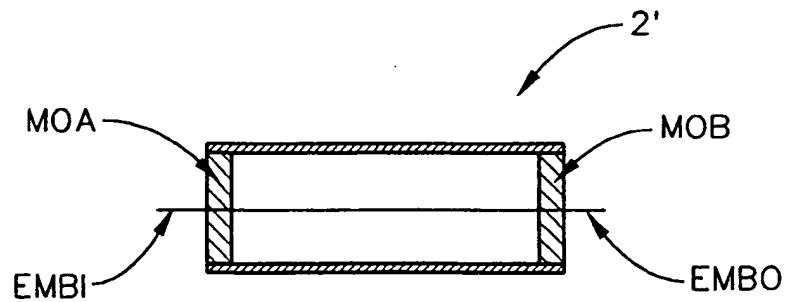
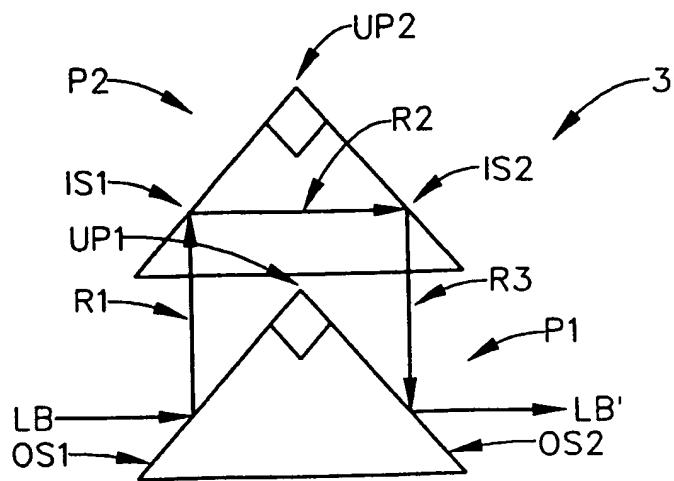
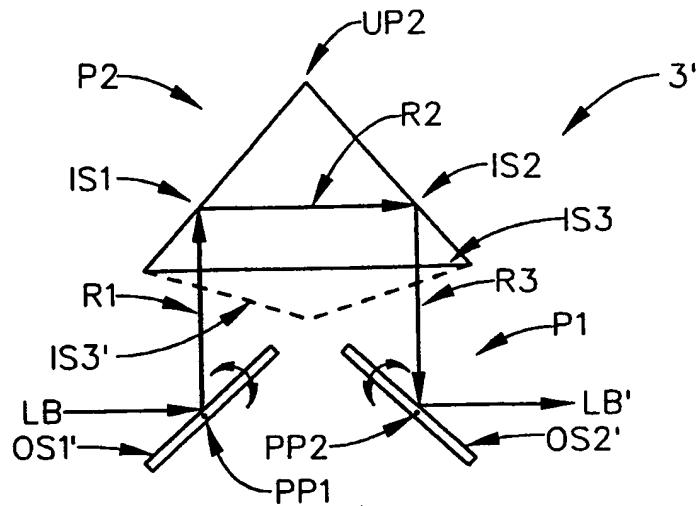


FIG. 10e



10f1



10f2

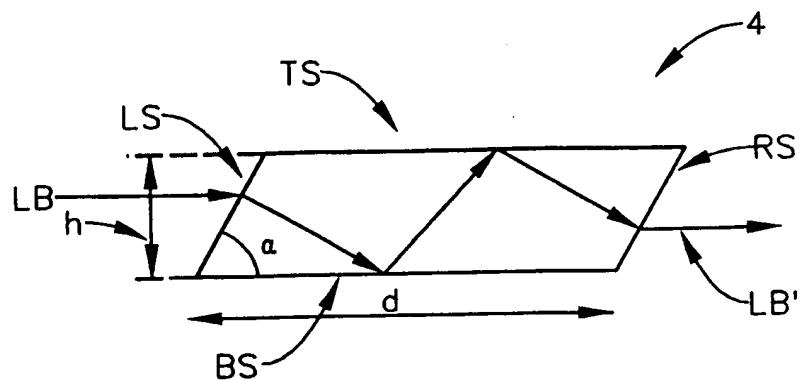


FIG. 10g

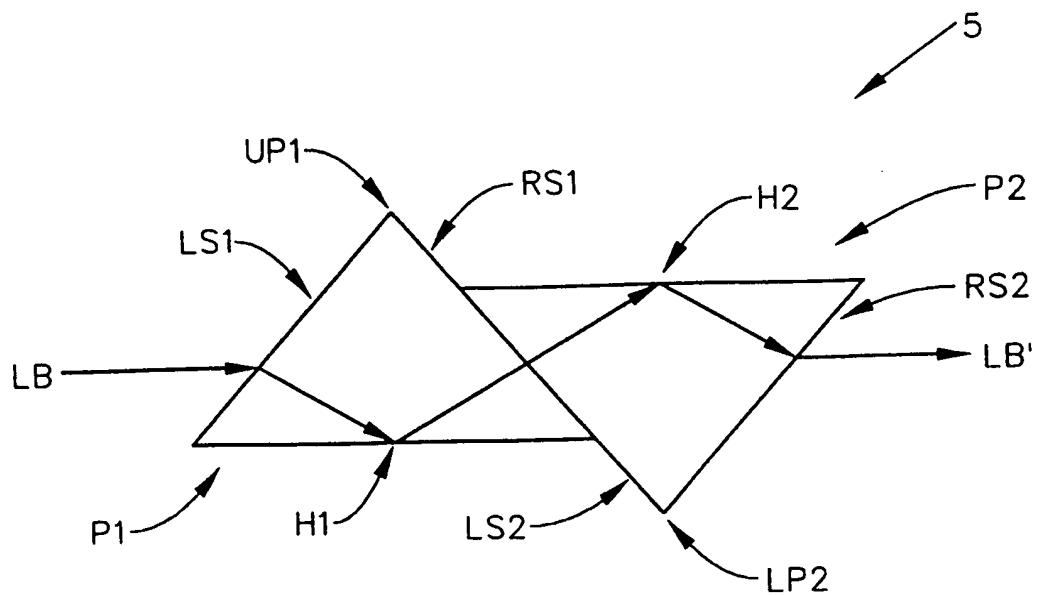


FIG. 10h

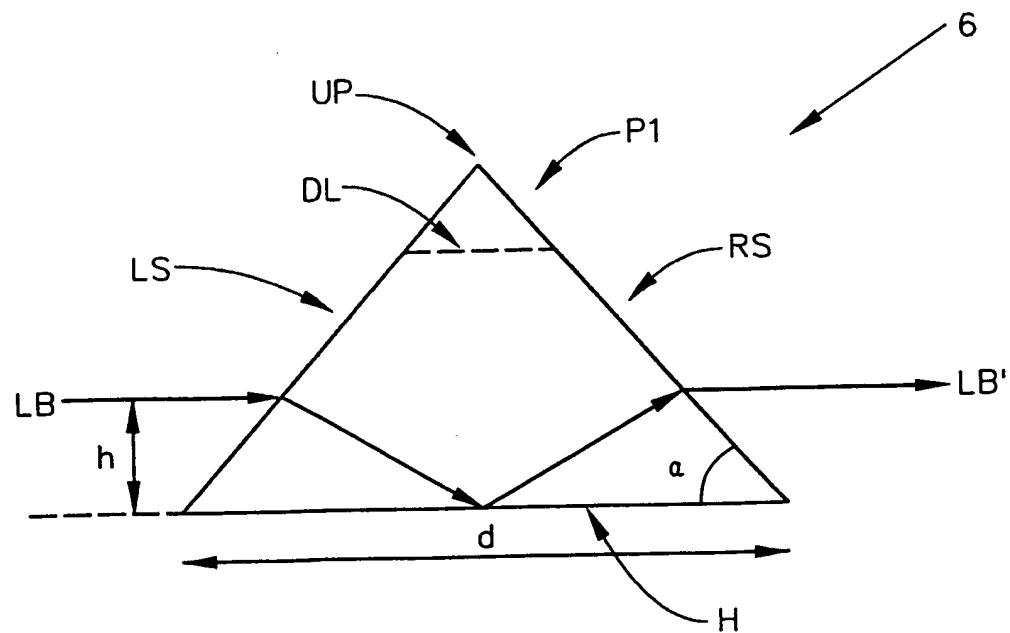


FIG. 10i

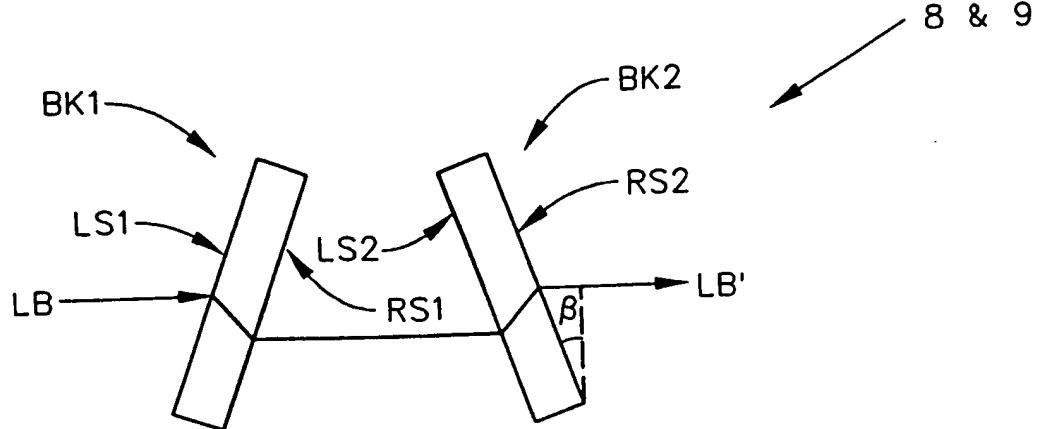


FIG10j1

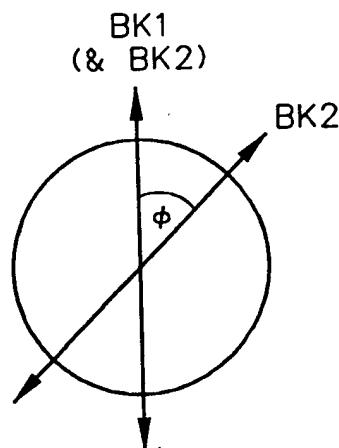


FIG. 10J2

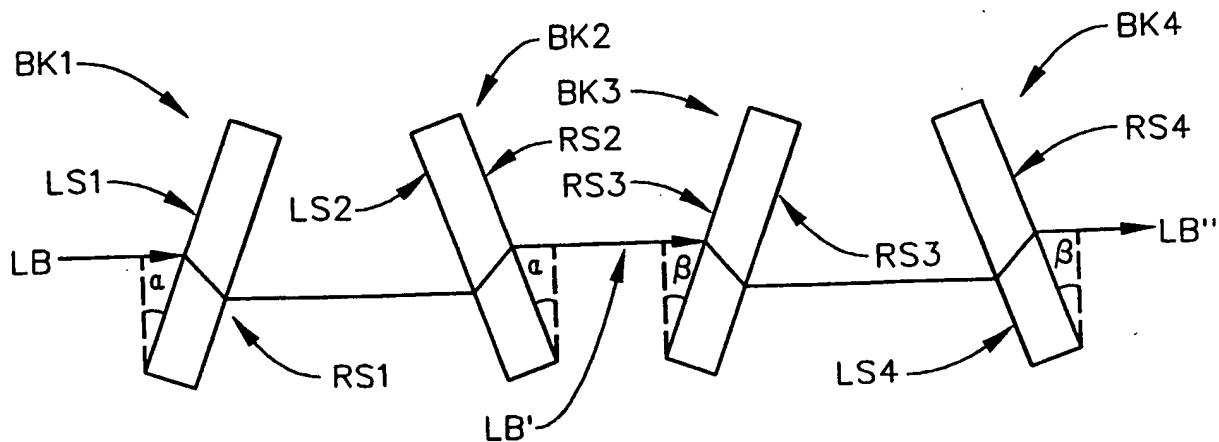


FIG. 10k1

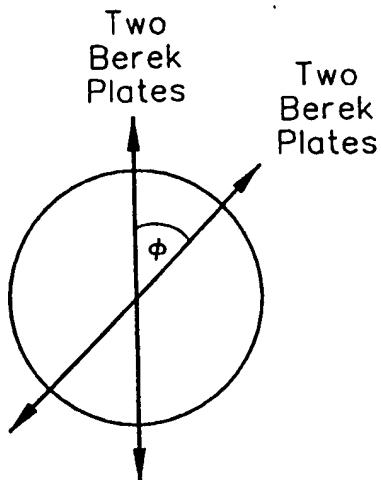


FIG. 10k2

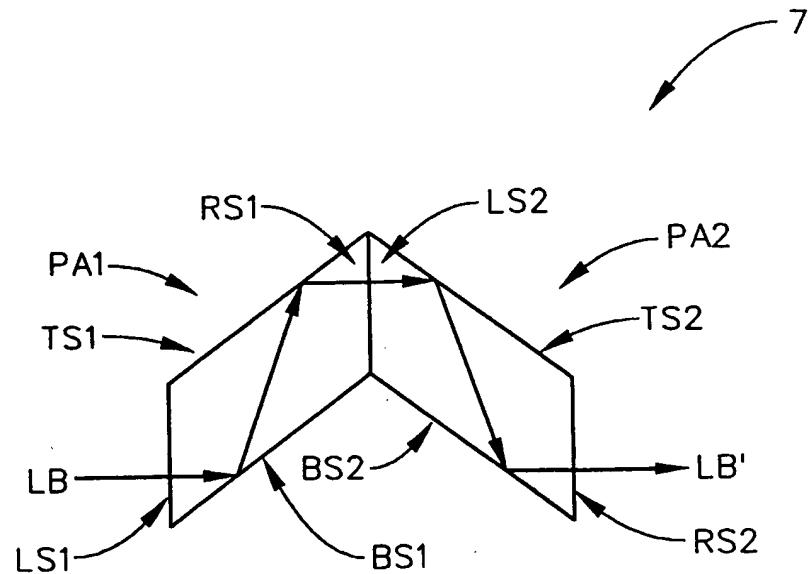


FIG. 10l

Providing a spectroscopic ellipsometer system comprising:  
a source of polychromatic electromagnetic radiation;  
a polarizer which remains fixed in position during  
data acquisition;  
a stage for supporting a sample system;  
an analyzer which remains fixed in position during  
data acquisition; and  
a detector system;

said spectroscopic ellipsometer system further comprising at  
least one means for discretely, sequentially, progressively  
modifying a polarization state of a beam of electromagnetic  
radiation provided by said source of polychromatic  
electromagnetic radiation through a plurality of  
polarization states, said means being present at at least  
one location selected from the group consisting of:  
between said polarizer and said stage for  
supporting a sample system; and  
between said stage for supporting a sample  
system and said analyzer.

For each of at least two ellipsometrically distinguished  
sample systems, obtaining at least one multi-dimensional  
data set(s) comprising magnitude as a function of wavelength  
and a function of a plurality of discrete settings of said  
at least one means for discretely, sequentially,  
progressively modifying a polarization state of a beam of  
electromagnetic radiation provided by said source of  
polychromatic electromagnetic radiation.

Providing a mathematical model of the ellipsometer system,  
including provision for accounting for the settings of said  
at least one means for discretely, sequentially,  
progressively modifying a polarization state of a beam of  
electromagnetic radiation provided by said source of  
polychromatic electromagnetic radiation.

By simultaneous mathematical regression onto said data sets,  
evaluating parameters in said mathematical model, including  
polarization state changing aspects of each of said  
plurality of discrete settings of said at least one means  
for discretely, sequentially, progressively modifying a  
polarization state of a beam of electromagnetic radiation  
provided by said source of polychromatic electromagnetic  
radiation.

FIG. 11

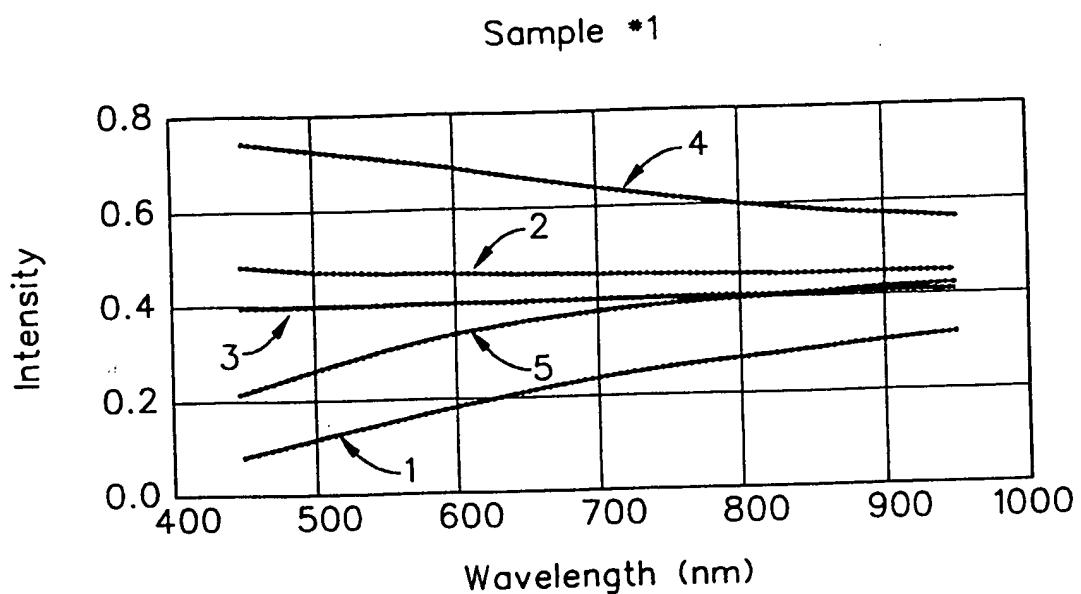


FIG. 12

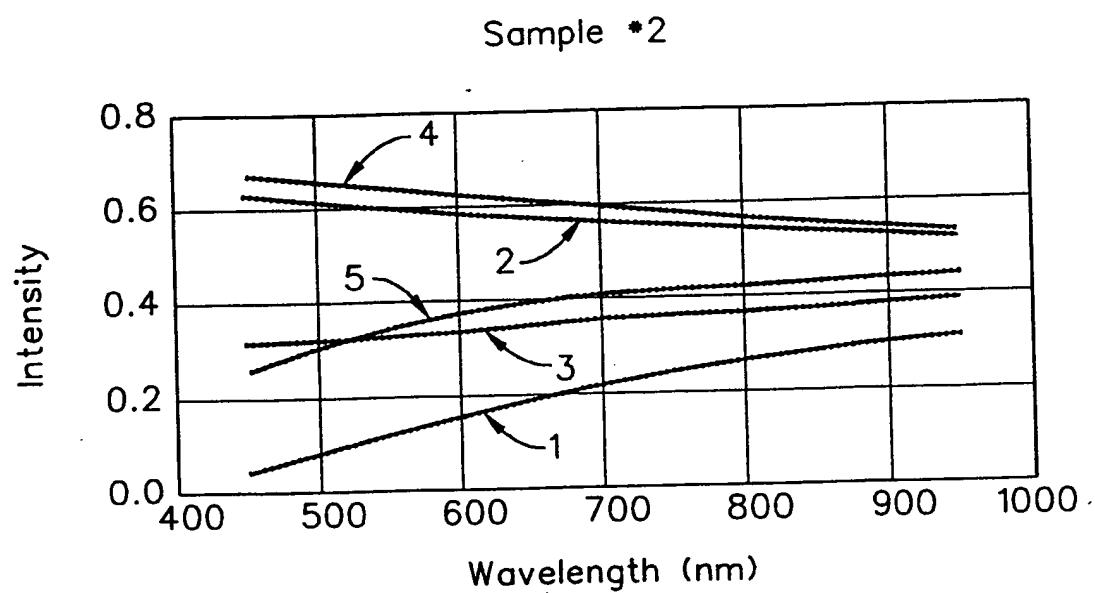


FIG. 13

Sample \*3

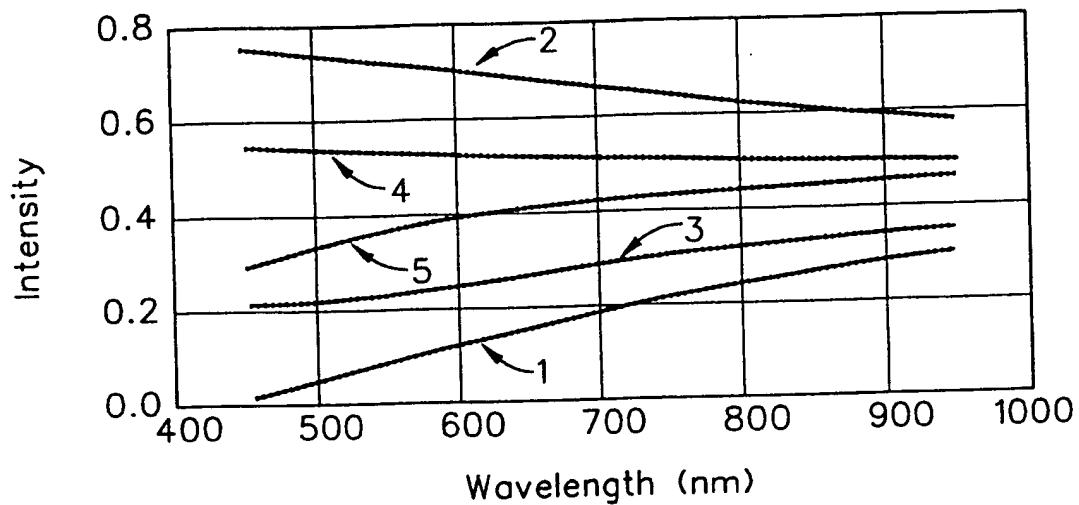


FIG. 14

Sample \*4

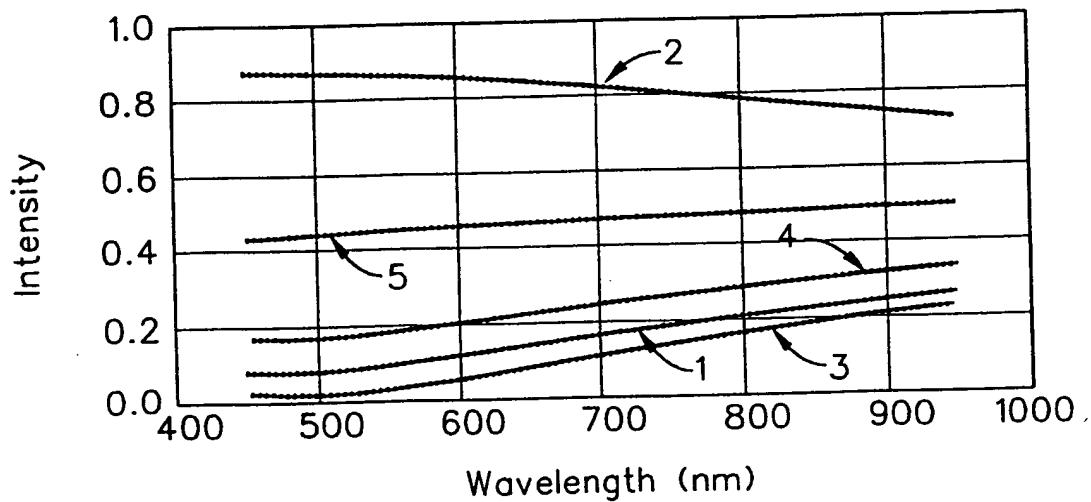


FIG. 15

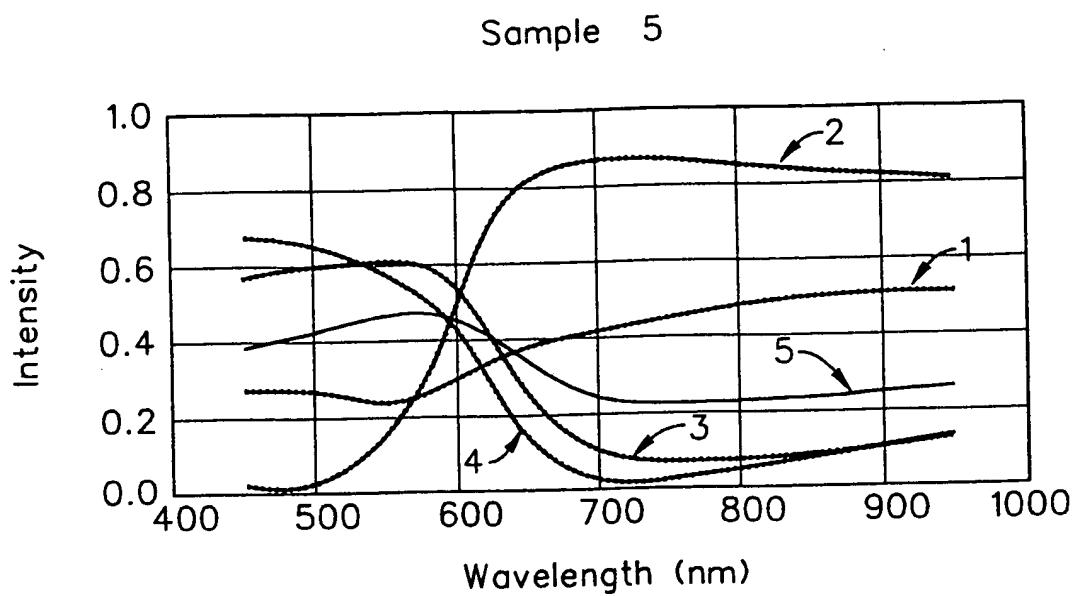


FIG. 16

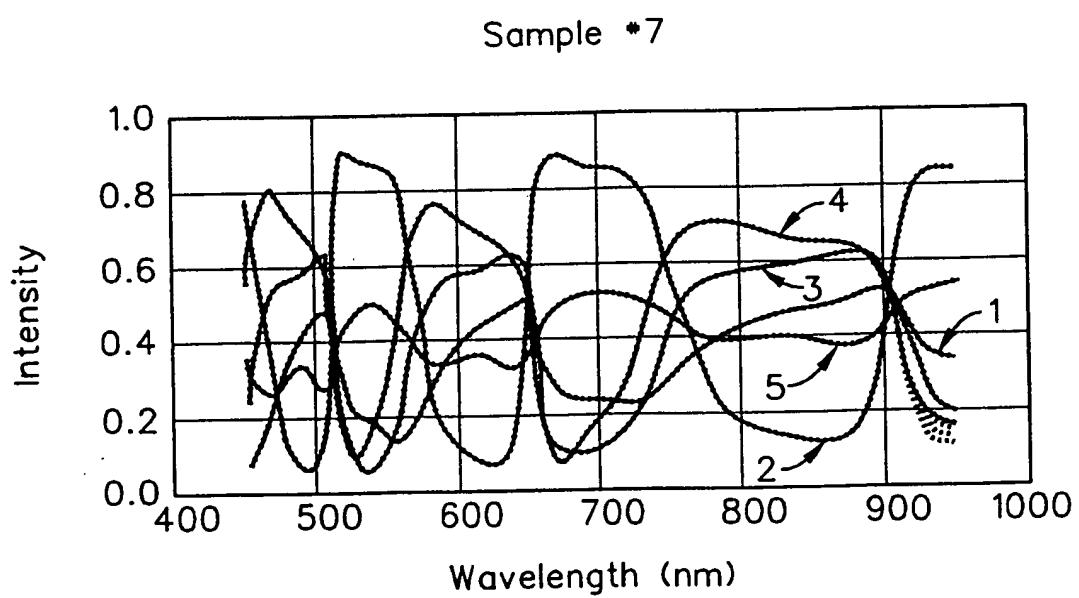


FIG. 17

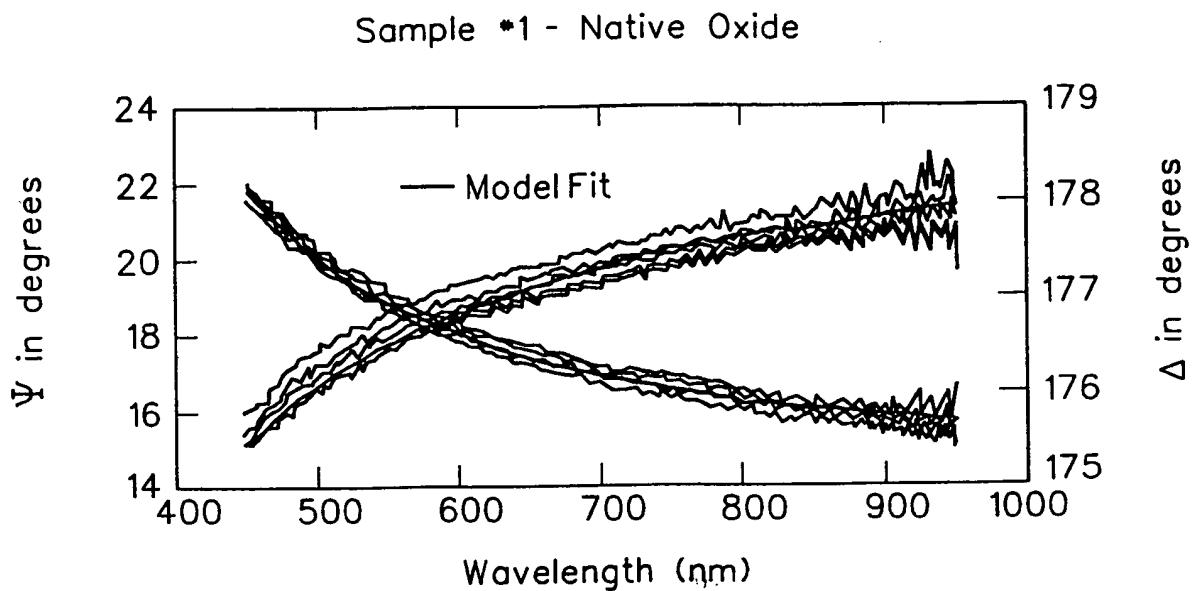


FIG. 19

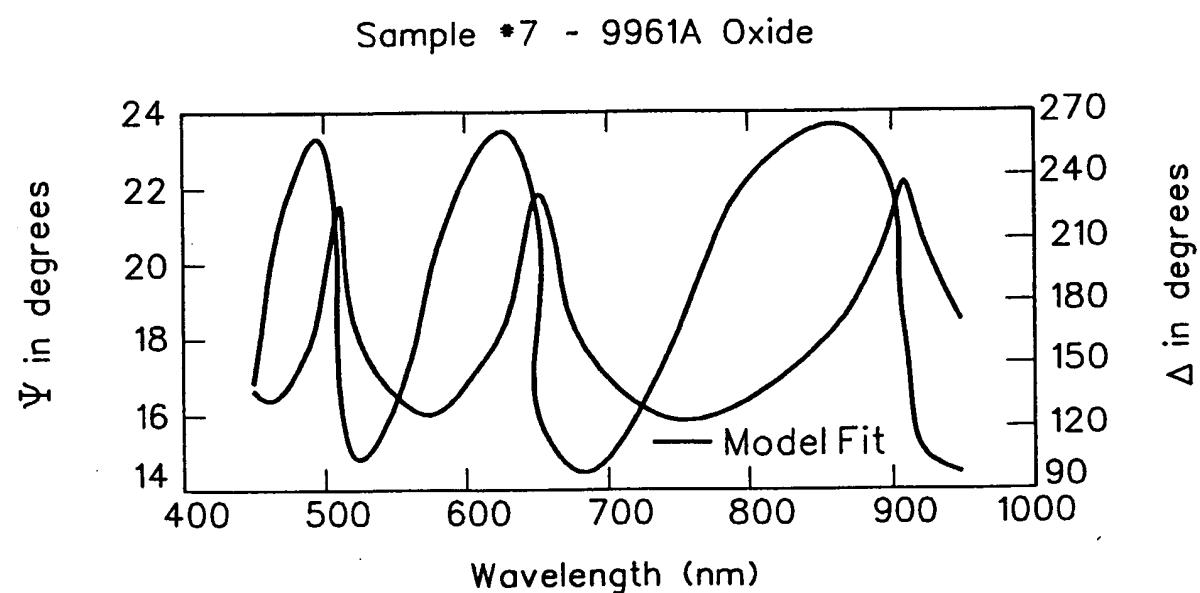


FIG. 20

Retardance Characteristics of Waveplates  
used in Dual Element Compensator Design

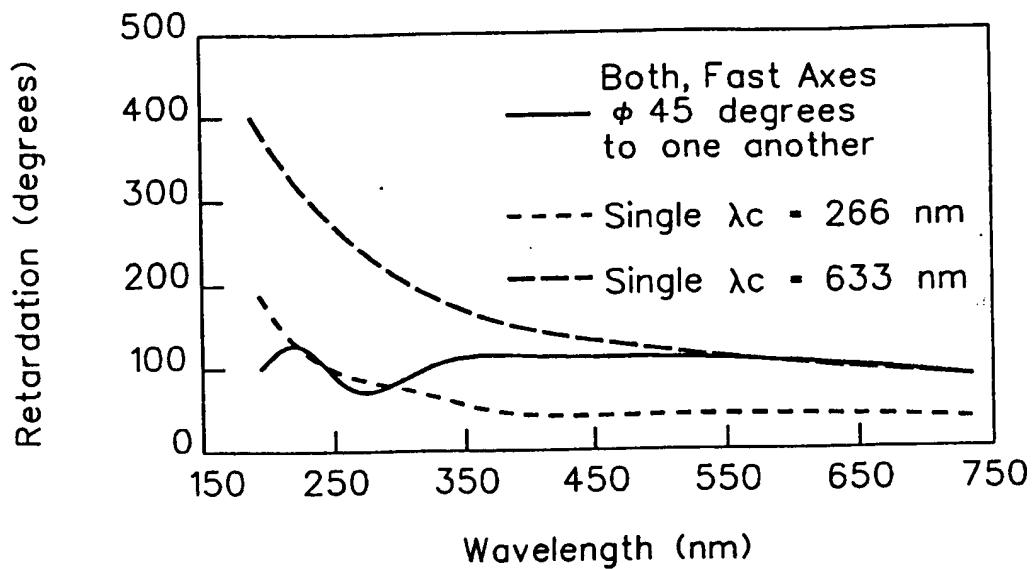


FIG. 22

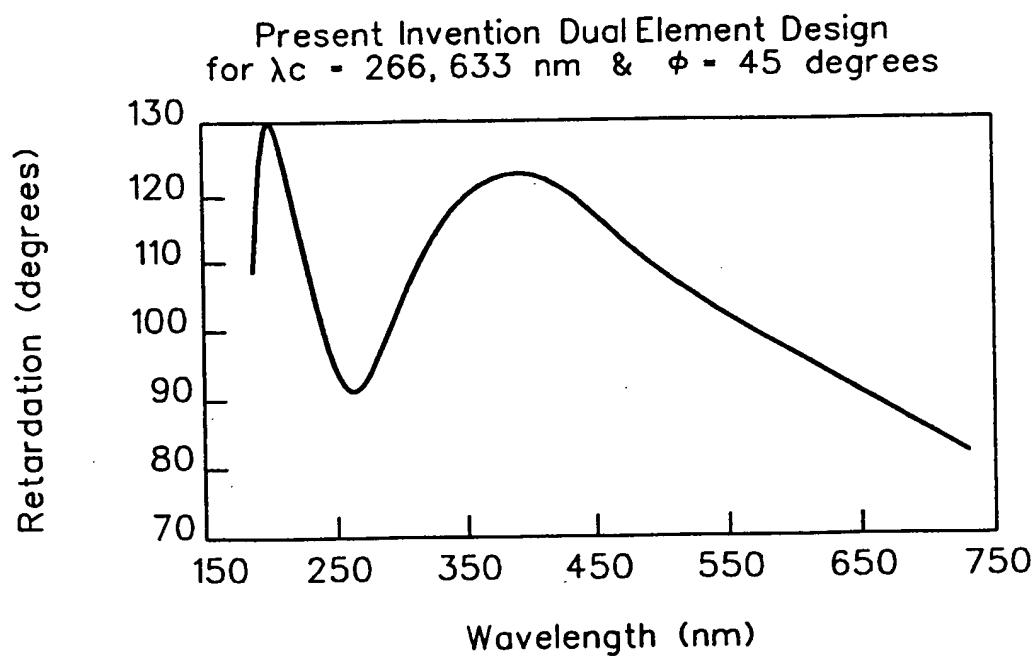


FIG. 23